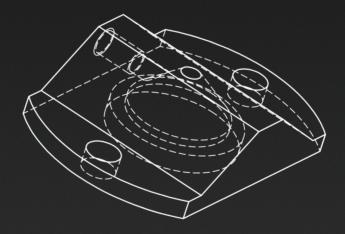




Targetry Products

SL-NOZ

Interaction regimes and physics require precise nozzle manufacturing



www.sourcelab-plasma.com

Unique solutions for nozzle manufacturing

Flow simulation

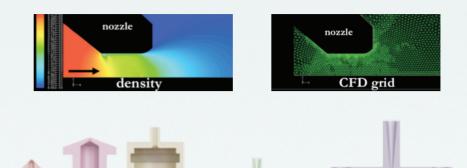
from a CAD file or specifications

Manufacturing

metal, ceramic, 3D printing

Characterization

interferometry from Phasics[®]



Specific nozzles for interaction regimes

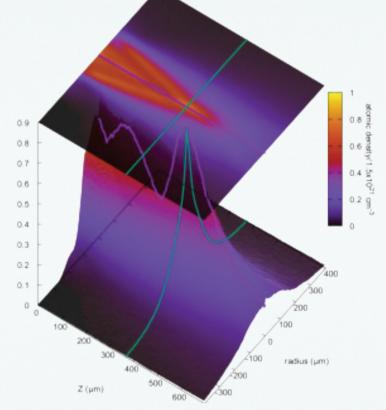
To make it possible for the experimentalist to explore precise interaction regimes and physics, SourceLAB developed a unique class of nozzles associated to precise manufacturing capabilities, that give access to specific plasma shapes and densities.

Each nozzle of the class can be easily fixed on a rapid valve to get the desired output flow.

In particular, our new class SL-Noz-Comp (see specifications), is specially designed to generate sub-100 μ m plasma of near-critical density, without external shocks from blades or cooling devices.

Importantly, it produces sub- μ m dense plasmas at a larger distance from the nozzle exit than the standard 400 μ m sonic nozzle. Therefore the lifetime of the nozzle is significantly increased while ensuring outstanding performances.

SourceLAB can also manufacture specific nozzles from your drawings and we offer characterization services.



This figure represents atomic density map and corresponding projection measured by interferometry at the exit of a typical SL-Noz-Comp nozzle. The backing pressure reads 320 bar.

Performances					
SL-NOZ Class	Physical application	Atomic density range	Thickness	Density gradient characteristic len- gth along gas flow	Density gradient length at jet edges
SL-NOZ-Comp	lon acceleration	10 ²⁰ -> 5.10 ²¹ cm ⁻³	100 µm	>1 mm	< 100 µm
SL-NOZ-I	Electron acceleration	10 ¹⁸ -> 10 ²⁰ cm ⁻³	0.1 -> 1 mm	> 2 mm	< 300 μm
SL-NOZ-II	Astrophysics - shocks	10 ¹⁸ -> 10 ²⁰ cm ⁻³	1 -> 2 mm	> 2 mm	< 300 μm
SL-NOZ-IV	Atomic physics	10 ¹⁵ -> 10 ¹⁷ cm ⁻³	1 mm	> 2 mm	< 300 µm
SL-NOZ-SLIT	Coherent X-ray am- plification (SXRL)	10 ¹⁹ -> 10 ²⁰ cm ⁻³	2 cm	> 2 mm	< 300 μm